

AMENDMENTS TO THE SPECIFICATION

Please replace the second full paragraph on Page 12 (lines 7-14) with the following paragraph rewritten in amendment format:

The micro vibration waveform W2 is set such that in the positive gradient waveform portion b1 the ink chamber 93 expands. In the negative gradient waveform portion ~~[[b3]]~~ b2, an applied voltage V1 is applied causing the ink chamber 93 to contract and be pressurized, however, the applied voltage V1 is not large enough to cause ink to be discharged from the nozzles 91. Namely, a structure is employed in which, by applying the voltage of the micro vibration waveform W2 to the piezoelectric elements 92, the meniscus is made to vibrate minutely so as to repeatedly move away from and then move towards the nozzle surfaces.